

Notice of References Cited	Application/Control No. 10/564,236	Applicant(s)/Patent Under Reexamination SOLO DE ZALDIVAR, JOSE	
	Examiner Vicki B. Booker	Art Unit 2813	Page 1 of 1

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*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
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*	B	US-5,087,578	02-1992	Endo et al.	438/309
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	M	US-			

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NON-PATENT DOCUMENTS

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	U	Van Zant, Peter; "Microchip Fabrication - A Practical Guide to Semiconductor Processing"; 2004; The McGraw-Hill Companies, Inc.; Fifth Edition; Pages 369 - 381.
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*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
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